IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner: Stouffer, Kelly M.

Art Unit: 1792

Confirmation No.: 5371

In re Application of:

Narwankar, et al.

Application No.: 10/772,893

Filed: February 4, 2004

For: TAILORING NITROGEN PROFILE IN SILICON OXYNITRIDE USING RAPID THERMAL ANNEALING WITH AMMONIA UNDER ULTRA-LOW PRESSURE

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT UNDER 37 CFR §1.111

Dear Examiner:

This is in response to the Office Action mailed March 6, 2009. Applicants respectfully request the Examiner to enter this Amendment and consider the following remarks.

The Listing of Claims begins on page 2 of this paper.

Remarks/Arguments begin on page 11 of this paper.

EFS Web on the	late below:	
June 8, 2009		
	Date of Deposit	
/Gigi Hoover/		
Gigi Hoover		

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